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Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Steven Verhaverbeke et al.

U.S. Serial No: 09/945,454

Filed: August 31, 2001

For: A METHOD AND APPARATUS
FOR PROCESSING A WAFER

Examiner: Moore, Karla A.

Art Unit: 1763

Assistant Commissioner for Patents
and Trademarks
Washington, D.C. 20231

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AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed December 5, 2002. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP _____
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